

**PRELIMINARY AMENDMENT**

Docket No. F0017/7000

Applicant: Jiankang Huang and Robert C. O'Handley
Serial No: 10/730,355
Filed: December 8, 2003
For: HIGH SENSITIVITY, PASSIVE MAGNETIC FIELD SENSOR AND
METHOD OF MANUFACTURE
Examiner: C. A. Renner
Art Unit: 2652

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Before conducting examination of the above-identified application, please enter the following amendments:

Amendments to the Claims begin on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.